

<b>Notice of References Cited</b>	Application/Control No. 10/589,309		Applicant(s)/Patent Under Reexamination CHIM ET AL.	
	Examiner Seng H. Lim		Art Unit 3714	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0009808 A1	01-2004	Gauselmann, Michael	463/25
	B	US-			
	C	US-			
	D	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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